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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/711,003	08/17/2004	Jason Lu	13155-US-PA	5002
31561	7590 07/26/2006		EXAM	INER
ЛANQ CH	YUN INTELLECTUAI	GARCIA, JOANNIE A		
7 FLOOR-1, NO. 100 ROOSEVELT ROAD, SECTION 2			ART UNIT	PAPER NUMBER
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TAIWAN			DATE MAILED: 07/26/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

	11					
	Application No.	Applicant(s)				
	10/711,003	LU, JASON				
Office Action Summary	Examiner	Art Unit				
	Joannie A. García	2823				
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the c	orrespondence address				
A SHORTENED STATUTORY PERIOD FOR REPL' WHICHEVER IS LONGER, FROM THE MAILING D. - Extensions of time may be available under the provisions of 37 CFR 1.1: after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period v. - Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim will apply and will expire SIX (6) MONTHS from , cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 05-10	<u>0-06</u> .					
2a)⊠ This action is FINAL. 2b)☐ This						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
closed in accordance with the practice under E	Ex parte Quayle, 1935 C.D. 11, 45	53 O.G. 213.				
Disposition of Claims						
4) Claim(s) 1 and 4-8 is/are pending in the applic	ation.					
4a) Of the above claim(s) is/are withdraw						
5) Claim(s) is/are allowed.						
6)⊠ Claim(s) <u>1 and 4-8</u> is/are rejected.	,					
7) Claim(s) is/are objected to.	7) Claim(s) is/are objected to.					
8) Claim(s) are subject to restriction and/o	r election requirement.					
Application Papers						
9) The specification is objected to by the Examine	er.					
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).						
11) The oath or declaration is objected to by the Ex	kaminer. Note the attached Office	Action or form PTO-152.				
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)).	on No ed in this National Stage				
Attachment(s) Di Notice of References Cited (PTO-892)	4) Interview Summary	(PTO-413)				
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail Da	ate				
B) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	5) Notice of Informal P 6) Other:	atent Application (PTO-152)				

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Claims 1, 4, and 5, are objected to because of the following informalities:

In claim 1, line 7, "an" before "laser beam" should be changed by --a--.

Appropriate correction is required.

The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

Claim 1 is rejected under 35 U.S.C. 102(a) as being anticipated by Chung et al (US 2003/0203589 A1).

The rejection is maintained as stated in the Office Action mailed 05-10-06, and as stated below.

Chung et al discloses providing a substrate 10 (Figure 1), and performing a laser marking processing operation over a surface of the substrate prior to performing a chemical mechanical polishing process, wherein at least a protrusion is formed over the surface of the substrate during the laser marking the processing operation, and wherein an energy of a laser beam of the laser marking processing operation is adjusted to reduce a step height of the protrusion compared to that without adjusting the parameter of the processing operation (Figures 1-2, and Paragraphs 0012-0015), wherein the processing operation comprises a laser marking process (Paragraph 0013).

Claims 4-8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Chung et al (US 2003/0203589 A1), in combination with Fang et al (US 2005/0158966 A1), and the following comments.

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The rejection is maintained as stated in the Office Action mailed 05-10-06, and as stated below.

Chung et al discloses fabricating a shallow trench isolation comprising providing a substrate 10 (Figure 1), performing a laser marking operation to form a laser mark 20 on the substrate (Figure 2), wherein at least a protrusion is formed during the laser marking operation due to an amassment of material, and wherein a parameter of the laser marking operation is adjusted in a manner to reduce a step height of the protrusion compared to that without adjusting the parameter (Paragraphs 0012-0014), forming a patterned mask layer 12/14 over the substrate (Figure 2), etching the substrate using the patterned mask layer as an etching mask to form a trench 22 (Figure 3).

Chung et al discloses the claimed invention except for forming an insulation layer over the substrate, wherein the insulation layer completely fills the trench, removing a portion of the insulation layer by performing a chemical-mechanical polishing process, and removing the patterned mask layer. Fang et al discloses fabricating a shallow trench isolation including forming a patterned mask layer 26 over a substrate 22 (Figure 2A, and Paragraph 0020), etching the substrate using the patterned mask layer as an etching mask to form a trench 30A (Figure 2C, and Paragraph 0022), forming an insulation layer 31 over the substrate, wherein the insulation layer completely fills the trench (Figure 2D, and Paragraph 0023), removing a portion of the insulation layer by performing a chemical-mechanical polishing process (Figure 2H, and Paragraph 0027), and removing the patterned mask layer 26 (Figures 2C-2D). It would have been within the scope of ordinary skill in the art to combine the teachings of Chung et al and Fang et al, to achieve formation of a CMP insulation layer filling the trench 22 of Chung el at, and removal of

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patterned mask layer 12/14 of Chung et al, by employing the disclosed steps of Fang et al.

Chung et al discloses the claimed invention except for adjusting the energy to a level below 1000 micro Joule, and reducing the step height to a level below 4 micrometer. It would have been obvious to one having ordinary skill in the art at the time the invention was made to determine a suitable energy and step height, since it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum or workable ranges involves only routine skill in the art. *In re Aller*, 105 USPQ 233.

In addition, the selection of a suitable energy and step height, it's obvious because it is a matter of determining optimum process conditions by routine experimentation with a limited number of species of result effective variables. These claims are prima facie obvious without showing that the claimed ranges achieve unexpected results relative to the prior art range. In re Woodruff, 16 USPQ2d 1935, 1937 (Fed. Cir. 1990). See also In re Huang, 40 USPQ2d 1685, 1688 (Fed. Cir. 1996)(claimed ranges or a result effective variable, which do not overlap the prior art ranges, are unpatentable unless they produce a new and unexpected result which is different in kind and not merely in degree from the results of the prior art). See also In re Boesch, 205 USPQ 215 (CCPA) (discovery of optimum value of result effective variable in known process is ordinarily within skill or art) and In re Aller, 105 USPQ 233 (CCPA 1995) (selection of optimum ranges within prior art general conditions is obvious).

Note that the specification contains no disclosure of either the critical nature of the claimed energy and step height or any unexpected results arising therefrom. Where

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patentability it's said to be based upon particular chosen energy and step height or upon another variable recited in a claim, the Applicant must show that the chosen energy and step height are critical. In re Woodruf, 919 F.2d 1575, 1578, 16 USPQ2d 1934, 1936 (Fed. Cir. 1990).

Applicant argues that Fang et al does not teach performing a laser marking operation to form a laser mark on the substrate, wherein at least a protrusion is formed during the laser marking operation due to an amassment of material, and wherein an energy of a laser beam of the laser marking operation is adjusted to reduce a step height of the protrusion compared to that without adjusting the parameter. However, Fang et al is not relied upon for that purpose.

THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Joannie García whose telephone number is (571) 272-1861. The examiner can normally be reached on Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew Smith, can be reached on (571) 272-1907. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

George Fourson Primary Examiner Art Unit 2823

JAG July 20, 2006

GFourson Primary Examiner